

## Flückiger Philippe

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**From:** Philippe Fluckiger <philippe.fluckiger@epfl.ch>  
**Sent:** mercredi 29 mars 2017 17:17  
**To:** Flückiger Philippe  
**Subject:** CMi Annual Review Meeting - Updated - Register Today

### ***Reminder - Register today*** (instructions below)

**NEW !** ([Current list of participants](https://cmi.epfl.ch/Participants_2017.pdf) : see [https://cmi.epfl.ch/Participants\\_2017.pdf](https://cmi.epfl.ch/Participants_2017.pdf))

### **EPFL - MicroNanoFabrication Annual Review Meeting**

#### *The Networking Forum*

- *presenting research achievements of the past year*
- *encouraging interaction among professors, researchers, students, and industry partners*
- *18th edition*

Date : Tuesday May 2nd, 2017

Time : 09h30 - 17h00

Place : EPFL, Forum Rolex Learning Center, [RLC E1 240](#)

#### Program :

- 10 invited speakers ([Program](https://cmi.epfl.ch/Program_2017.pdf): see [https://cmi.epfl.ch/Program\\_2017.pdf](https://cmi.epfl.ch/Program_2017.pdf))
- 200 posters presented by the authors (the list will be published soon)

The posters show the research projects realized during the last 12 months in the EPFL Center of MicroNanoTechnology (CMi).

The scope of the forum is *Micro & Nano Fabrication Techniques* used in the following fields:

- Micro and Nanoelectronics (Soft Bioelectronic, 3D Integration, Nanowires, High-Q Resonators, New materials, ...)
- Biomedical Applications (Microfluidics, Microelectrodes, Lab on a Chip, Probes, Neuroprosthetics, ...)
- MEMS, NEMS (Sensors and Actuators, Motors, Tweezers, Artificial Muscles, Micro and Nanomechanics, ...)
- Optics (Nanophotonics, Optomechanics, Photonic Crystals, MOEMS, Optofluidics, Fibers, ...)
- Nanostructure Physics (VCSELs, Quantum Opto-Electronics, III/V Devices, Nanotubes, Nanowires, Nanomechanics, ...)
- Material Sciences (Photovoltaic Materials, Piezoelectric materials, Nanoparticles, Energy Harvesting, Micro Fuel Cells, ...)
- Fabrication Technologies (Lithography, Etching, Thin Films, ALD, EBEAM, CMP, Self assembly, Inkjet Printing, PDMS, ...)
- Metrology and Defect Analysis (SEM, FIB, Ellipsometry, Reflectometry, AFM, EDX, Stress, Conductivity, ...)
- Packaging and Assembly (Grinding, Wire Bonding, Encapsulation, ...)

More than 600 people attended the previous edition, including :

- professors,
- industrials,
- researchers,
- students.

The meeting is organized by the EPFL Center of MicroNanoTechnology (CMi)

**Registration is required by sending an email to : [secretaries.cmi@epfl.ch](mailto:secretaries.cmi@epfl.ch)**

- name : .....
- first name : .....
- organization : .....
- email address : .....

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